

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Hada et al.
Appl. No.	:	10/563,705
Filed	:	January 5, 2006
For	:	RESIST COMPOSITION, LAMINATE, AND METHOD FOR FORMING RESIST PATTERN
Examiner	:	Chu, John S Y
Group Art Unit	:	1795

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed **October 6, 2008**, please consider the following remarks:

**The listing of claims** begins on page 2 of this paper. No amendments have been made.

**Remarks** begin on page 5 of this paper.